Application Number:	100	10678766					
Filing Date:	02-	02-Oct-2003					
Title of Invention:	ME	METHOD OF GROWING OXIDE THIN FILMS					
First Named Inventor/Applicant Name:	Eva	Eva Tois					
Filer:	Da	David K. Buckingham/Jonathan Pan					
Attorney Docket Number:	SE	SEPP21.001C1					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees	;						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810